



Sheet 1 of 1

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 115556	APPLICATION NO. 10/766,806	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT(S) Takao SAITO et al.		
				FILING DATE January 30, 2004	GROUP <u>1762</u>	
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
FOREIGN PATENT DOCUMENTS						
<i>VH</i>		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
<i>VH</i>	1.	JP A 62-136569	6/19/1987	JAPAN		
<i>VH</i>	2.	JP A 2002-339072 w/abstract & transl.	11/27/2002	JAPAN		
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)						
EXAMINER <i>[Signature]</i>				DATE CONSIDERED <u>9/14/05</u>		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.						



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<i>JH</i>	1.	US 2002/0170495 A1	11/21/2002	NAKAMURA et al.		
<i>JH</i>	2.	US 2002/0182319 A1	12/5/2002	BEN-MALEK et al.		
<i>JH</i>	3.	5,236,511	8/17/1993	ETZKORN et al.		
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	4.	Frank Jansen et al.; "Thin film deposition on inside surfaces by plasma enhanced chemical vapor deposition"; XP000474735; Thin Solid Films, Elsevier, Vol. 252, No. 1; November 15, 1994; pp 32-37				
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Date: November 19, 2004